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Analog.6834

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Gormley et al.

GROUP: 2822

SERIAL NO: 10/617,427

EXAMINER: P.E. Perkins

FILED: July 11, 2003

FOR: A METHOD FOR FORMING A MICRO-MECHANICAL COMPONENT IN A SEMICONDUCTOR WAFER, AND A SEMICONDUCTOR WAFER COMPRISING A MICRO-MECHANICAL COMPONENT FORMED THEREIN

Mail Stop Amendment  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Sir:

**RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT**

In response to the Notice of Non-Compliant Amendment, a copy of which is enclosed, Applicants hereby submit a replacement "Remarks" section of the previously submitted amendment, which now contains the required attorney signature. No new matter has been entered.

The application is now considered to be in condition for allowance, and an early indication of the same is earnestly solicited.

Respectfully submitted,

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**CERTIFICATE OF MAILING (37 CFR 1.8(a))**

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United State Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Sarah E. Kennedy  
(Type or print name of person mailing letter)

Date: 6/1/05

  
(Signature of person mailing paper)